

Transaction Information

ToolId	SNK2661
ToolStatus	Connected Idle
Location	Malta, NY
WaferSize	300 mm
FabSection	Clean

General Product Information

VendorSupplier	TEL
Model	FSI ORION
Vintage	2012
SerialNo	1501-0018-0312
AssetDescription	
SoftwareVersion	8.67.15.2
CIM	E84, SECS/GEM, GEM300, Interface A
Process	PassivationCLN_BEOL

Hardware Configuration (Fab)

SystemType	Description	Quantity	Status
Main System	ORION BEOL Single Wafer Cleaning System	1	OK
Factory Interface	FOUP	4	OK
Handler System	Staubli Tx Robot	1	OK
Handler System	Single 300mm End Effector	1	OK
Handler System	Power Distribution System	1	OK
Options System	Standard Spin Clean Modules for Low O2/dHF/BEOL Processing	1	OK
Options System	8 Spin Clean Chambers	1	OK
Options System	CO2 Inject Module DI Water Supply	1	OK
Others	Wafer Spin Dry in N2 or N2/IPA Controlled Environment	1	OK

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
NA		

Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	0

hardwarefab

Mainbody



manufactureserial

Plate



Additional Configuration Files